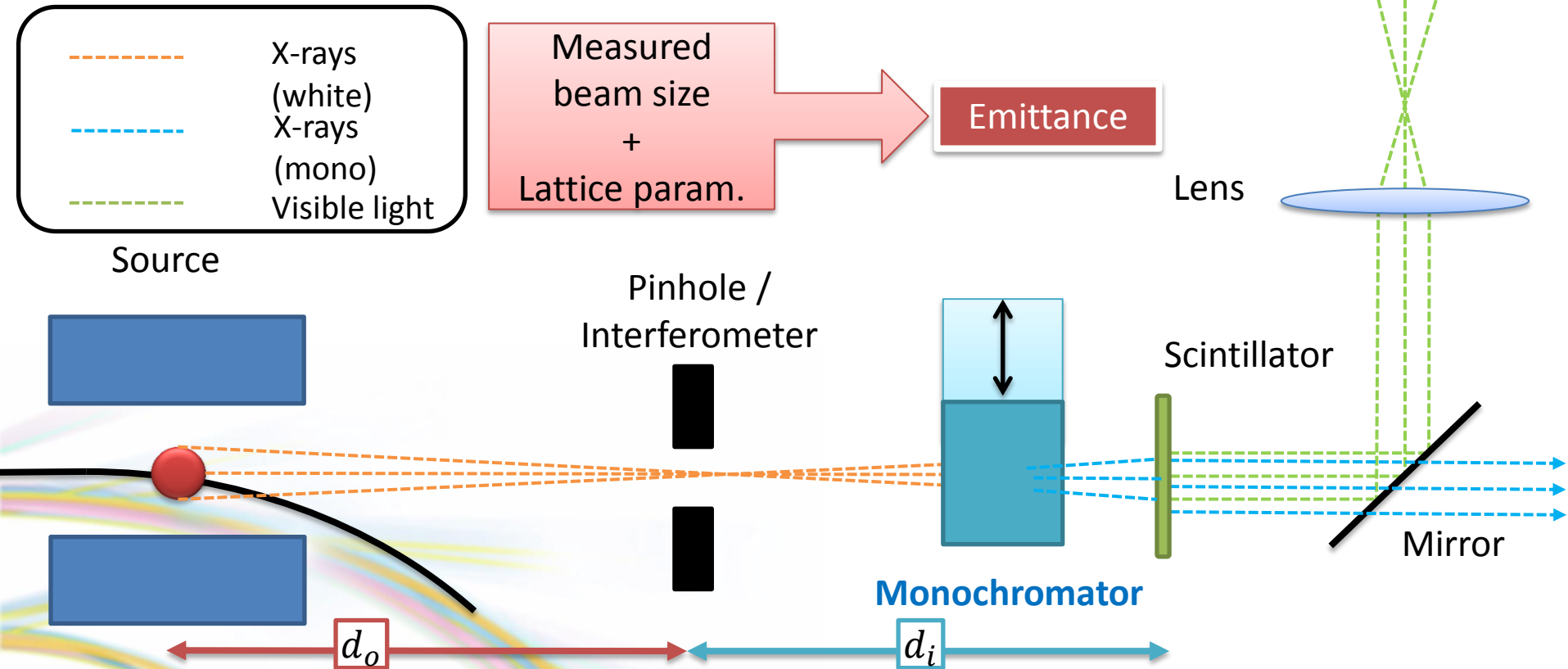


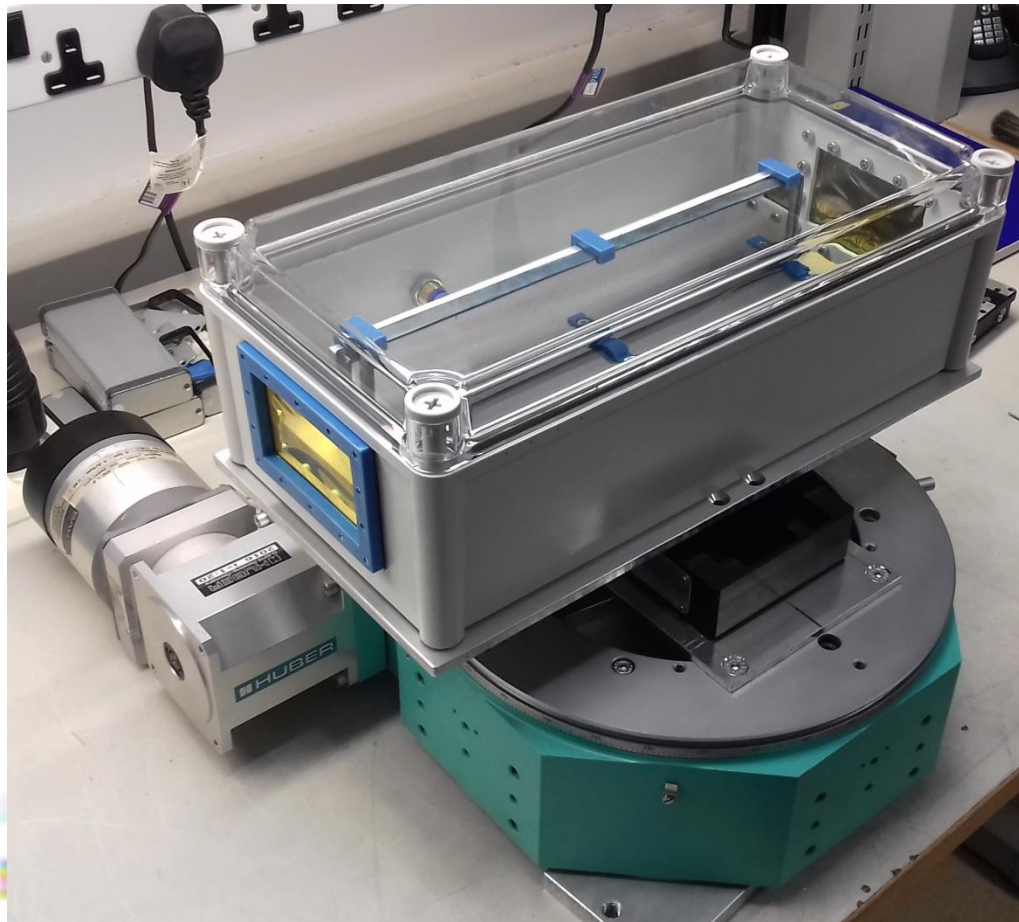
# Diagnostics X-ray Beamline at Diamond Light Source

Lorraine Bobb



- **Improve beam size resolution of X-ray pinhole camera:**  
Monochromatic → Match pinhole size to energy → Minimise PSF  
Best spatial resolution  $\sim 1 - 3 \mu\text{m}$
- **Develop X-ray interferometer which can measure smaller beam sizes** (-requires monochromatic X-ray beam).





# X-ray Interferometer

Owing to limited space in the experimental hutch the maximum distance between the double pinhole and the detector was  $L_{exp} = 1.40$  m. This is a relatively small distance for the small diffraction angles occurring at this short wavelength. To observe interference of both diffracted waves they must sufficiently overlap each other after propagation from the pinholes to the detector. The width of the first diffraction minimum  $2R$  in the distance  $L$  behind a pinhole of diameter  $d$  at a wavelength  $\lambda$  is given by the Airy criterion,  $2R = 1.22L\lambda/d$ . The degree of overlap,  $O$ , can be expressed as

$$O = 1 - \frac{D}{2R} = 1 - \frac{Dd}{1.22L\lambda} \quad (3)$$

(see Fig. 2). A complete overlap of the diffraction maxima of  $O \simeq 1$  is reached for very large values of  $L$ . Let us assume an overlap of at least 0.8 to obtain an evaluable interference pattern from the

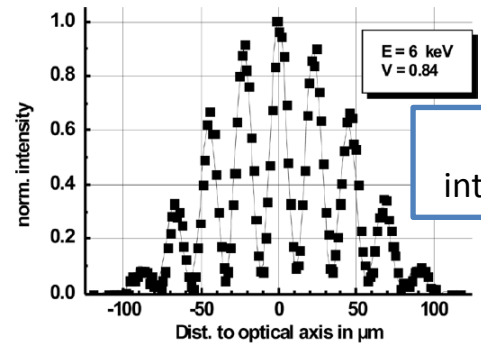
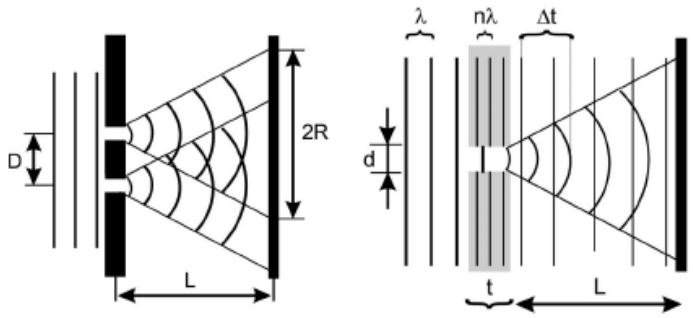
**Overlap @ 15 keV  $\approx$  0.79**  
**Overlap @ 25 keV  $\approx$  0.66**



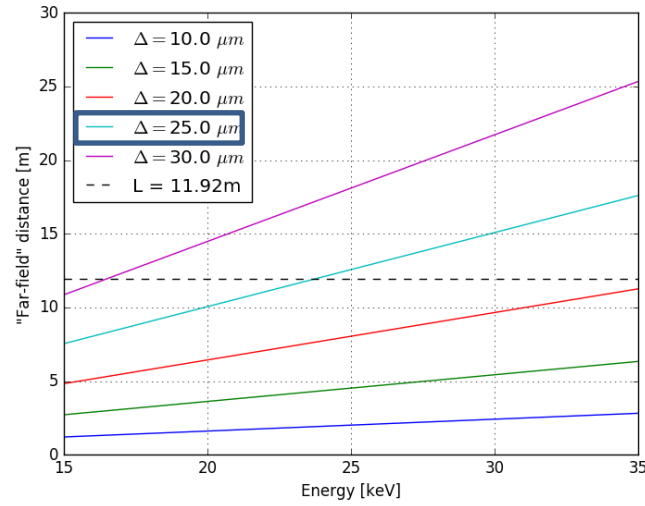
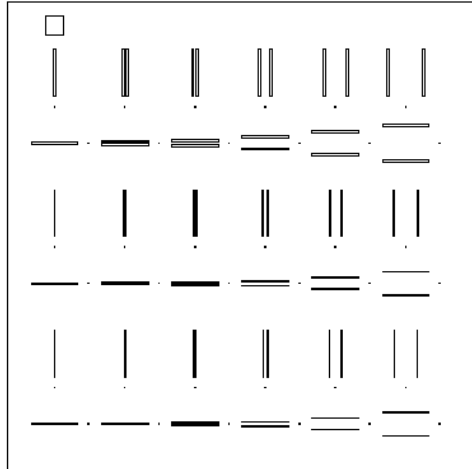
Note that minimum distance for far-field is

$$\frac{\Delta^2}{\lambda} = L_{min},$$

however in reality  $L_{min} \ll L$  which is not satisfied for all object sizes.



Example interferogram



[1] Pinhole interferometry with coherent hard X-rays- Wolfram Leitenberger, Horst Wendrock, Lothar Bischoff and Timm Weitkamp

	Borrowed from Optics group	Incoatec
Dimensions	300 mm x 50 mm	Approx 40mm x 100mm
D-spacing	4.8 nm	4 nm
Multilayers	Mo/Si with N=100 layer-pairs deposited on float glass	Tungsten/Boron Carbide (B4C) with 200 pairs
Comment	At 12 keV, it will have a Bragg angle of $\sim 0.67$ deg, giving a beam-deflection of $\sim 23$ mm at 1m	



# Extra Slides

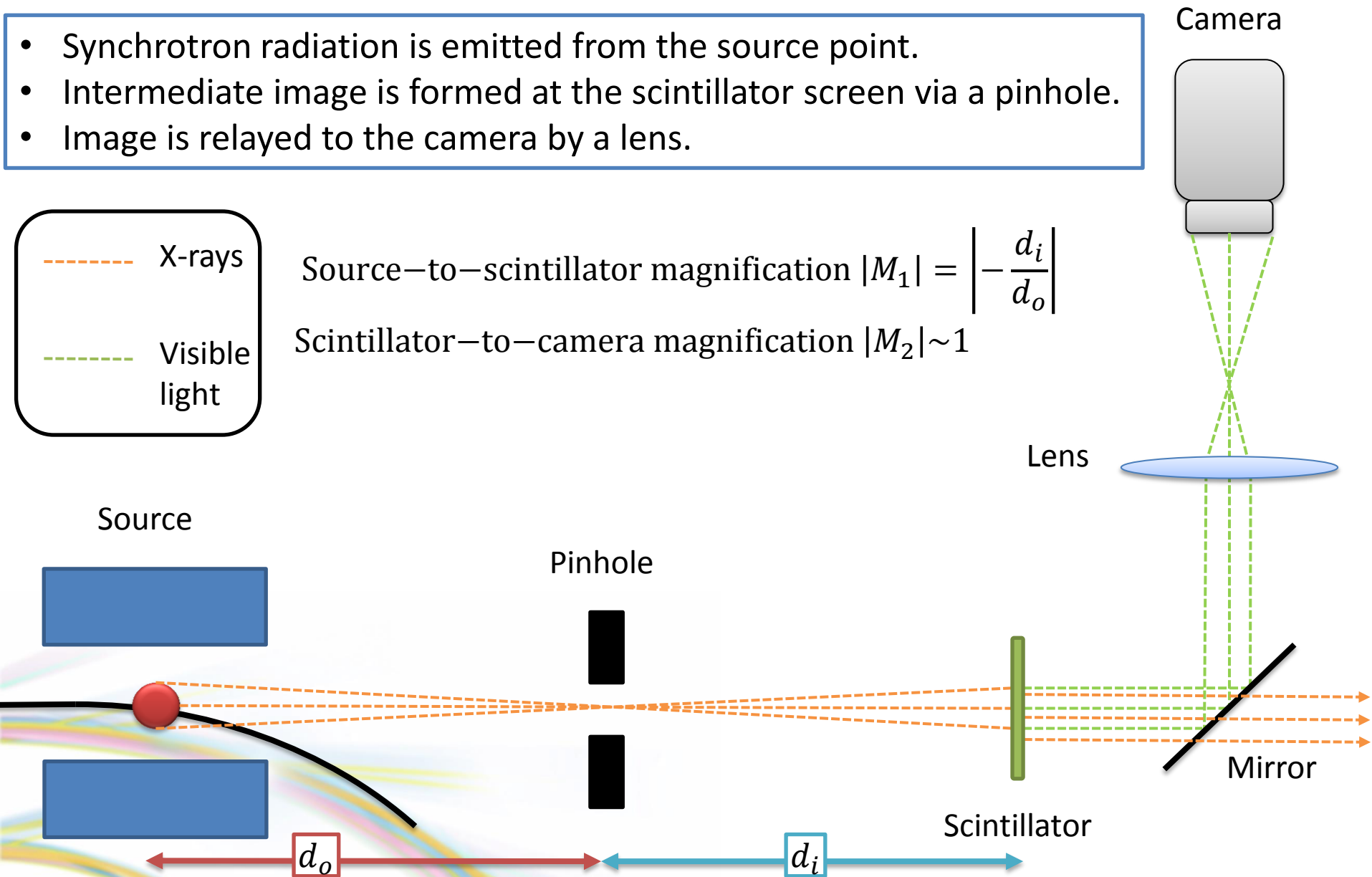


- Synchrotron radiation is emitted from the source point.
- Intermediate image is formed at the scintillator screen via a pinhole.
- Image is relayed to the camera by a lens.

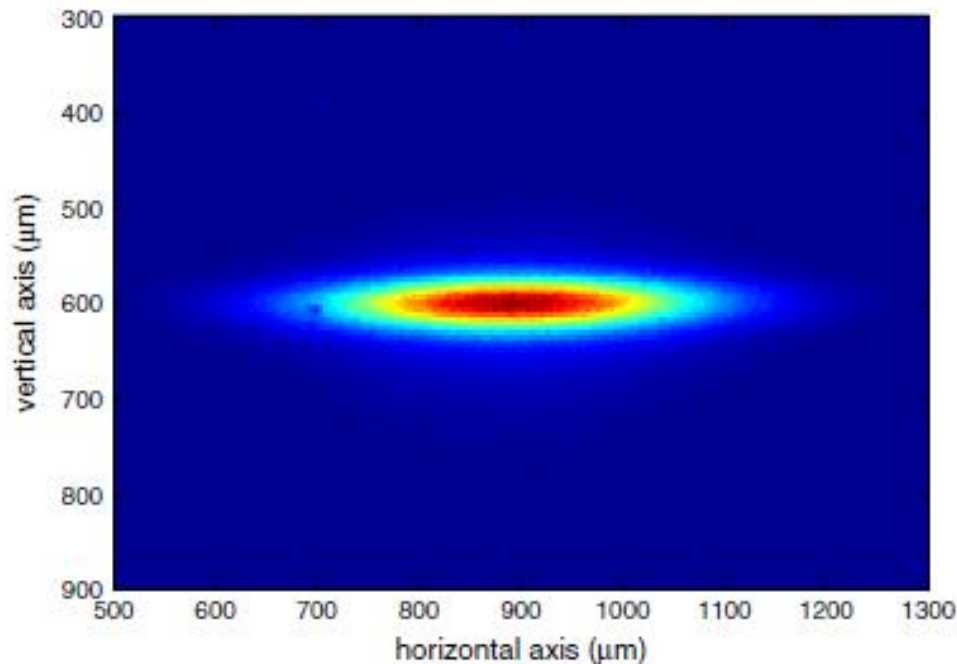
----- X-rays

----- Visible light

Source-to-scintillator magnification  $|M_1| = \left| -\frac{d_i}{d_o} \right|$   
 Scintillator-to-camera magnification  $|M_2| \sim 1$



X-ray pinhole cameras **measure the transverse profile** of the beam, **from which the emittance may be calculated.**



Example image from Diamond Light Source in 2010, from which the emittance can be calculated [4, 5].



At Diamond using two pinhole cameras at different locations:

1. **Fit a 2D Gaussian** to obtain horizontal and vertical imaged sizes  $\sigma_{x_{1,2}}^{image}$  and  $\sigma_{y_{1,2}}^{image}$  respectively.
2. **Deconvolve and scale** using magnification to obtain the electron beam sizes e.g. Gaussian subtraction in quadrature:

$$\sigma_{y_1} = \frac{\sqrt{(\sigma_{y_1}^{image})^2 - \sigma_{PSF}^2}}{M_1}$$

3. Given the lattice parameters, **solve** the following matrix equation to obtain the horizontal and vertical emittances  $\varepsilon_{x,y}$ , and energy spread  $\sigma_e$ :

$$\begin{bmatrix} \sigma_{x_1}^2 \\ \sigma_{x_2}^2 \\ \sigma_{y_1}^2 \\ \sigma_{y_2}^2 \end{bmatrix} = \begin{bmatrix} \beta_{x_1} & 0 & \eta_{x_1}^2 \\ \beta_{x_2} & 0 & \eta_{x_2}^2 \\ 0 & \beta_{y_1} & \eta_{y_1}^2 \\ 0 & \beta_{y_2} & \eta_{y_2}^2 \end{bmatrix} \begin{bmatrix} \varepsilon_x \\ \varepsilon_y \\ \sigma_e^2 \end{bmatrix}$$

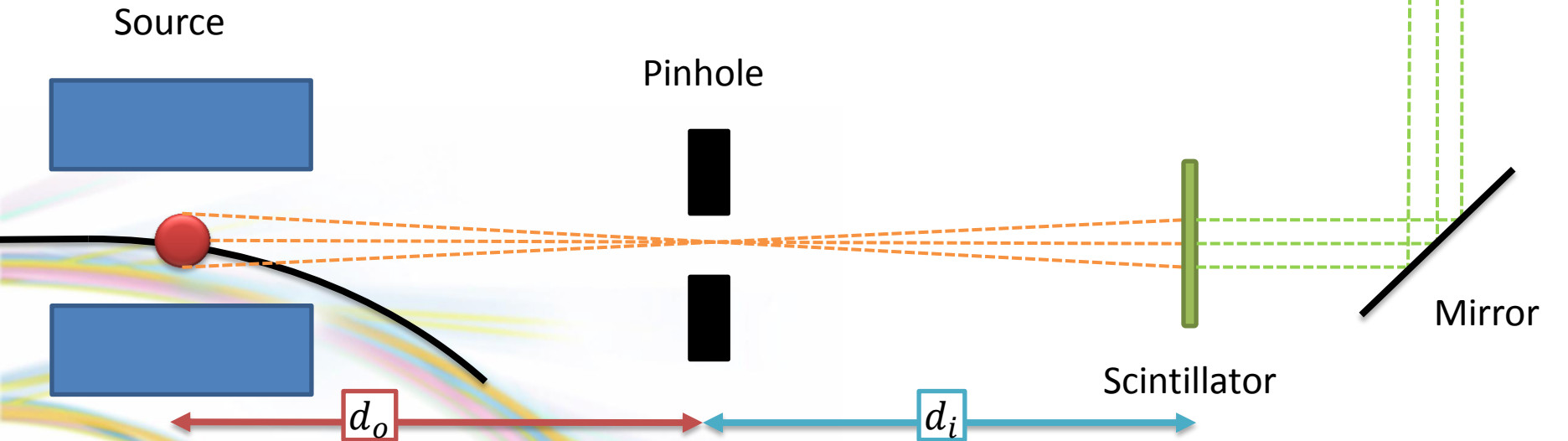
- Indirect emittance measurement
- **Point Spread Function** (Gaussian approx.) contribution to beam size measurement [4]:

$$\sigma_{PSF}^2 = \sigma_{Pinhole}^2 + \sigma_{Camera}^2 > 0$$

where

$$\sigma_{Pinhole}^2 = \sigma_{Diffraction}^2 + \sigma_{Aperture}^2$$

$$\sigma_{Camera}^2 = \sigma_{Screen}^2 + \sigma_{Lens}^2 + \sigma_{Sensor}^2$$



$$\sigma_{PSF}^2 = \sigma_{Pinhole}^2 + \sigma_{Camera}^2 > 0$$

Source resolution for optimised pinhole camera, given current spatial constraints at Diamond:

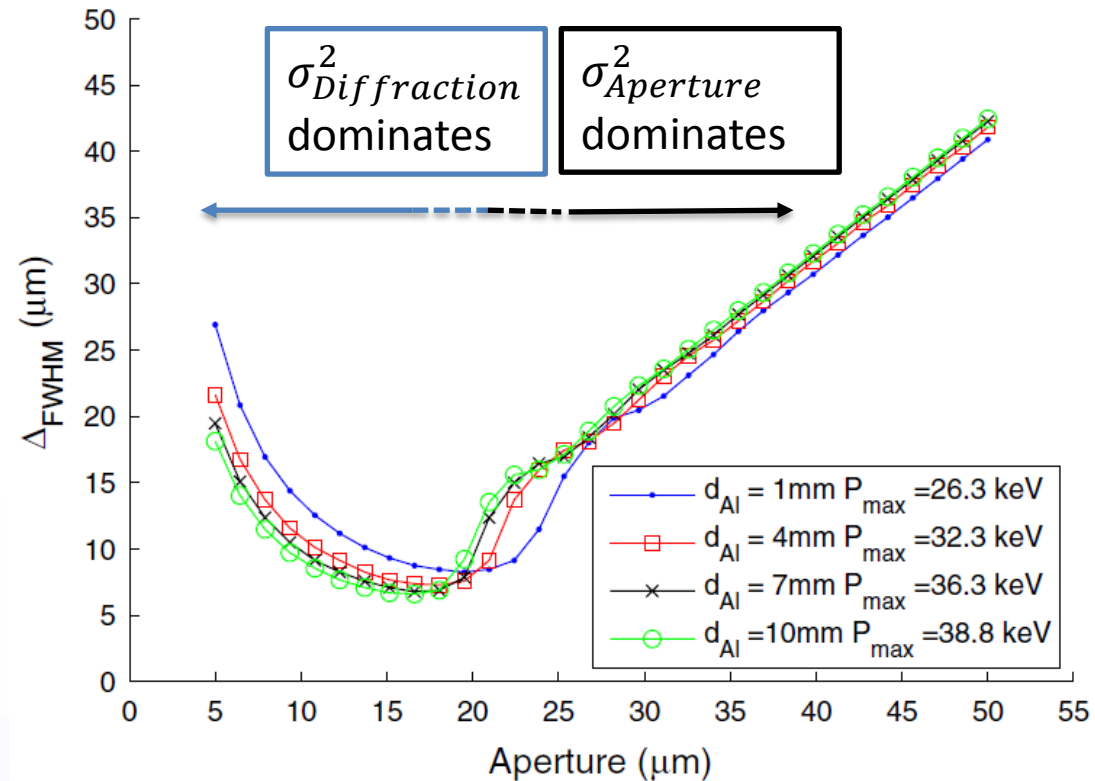
$$\frac{\left(\frac{\Delta_{FWHM}}{2.35}\right)}{|M_1|} \sim \frac{\left(\frac{6 \mu\text{m}}{2.35}\right)}{2.65} \sim 1 \mu\text{m}$$

with  $\sigma_{Camera}^2 = 0$ .

Source resolution incl. contribution from camera using a 5 $\mu\text{m}$  P43 screen [4]:

$\sim 3 \mu\text{m}$

Phys. Rev. ST Accel. Beams **13**, 022805 (2010)



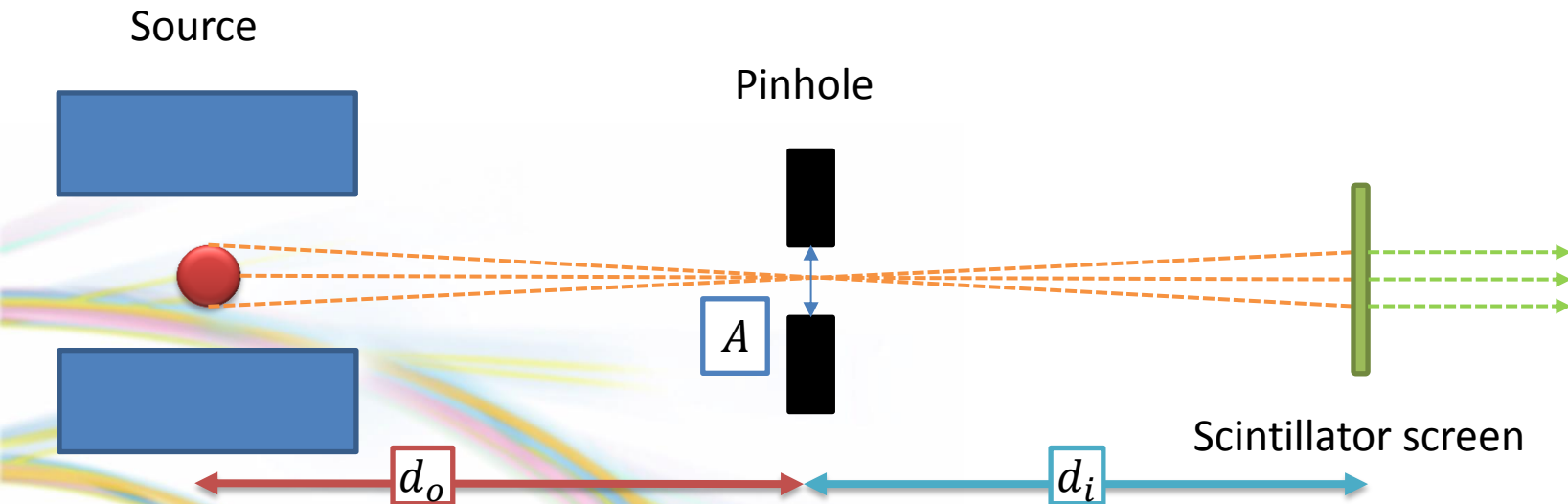
- Spatial constraints

- For sufficient source-to-screen magnification ( $|M_1| = \left| -\frac{d_i}{d_o} \right| \geq 2$ ):

- X-ray path length ( $d_o + d_i$ )  $\geq 10\text{m}$

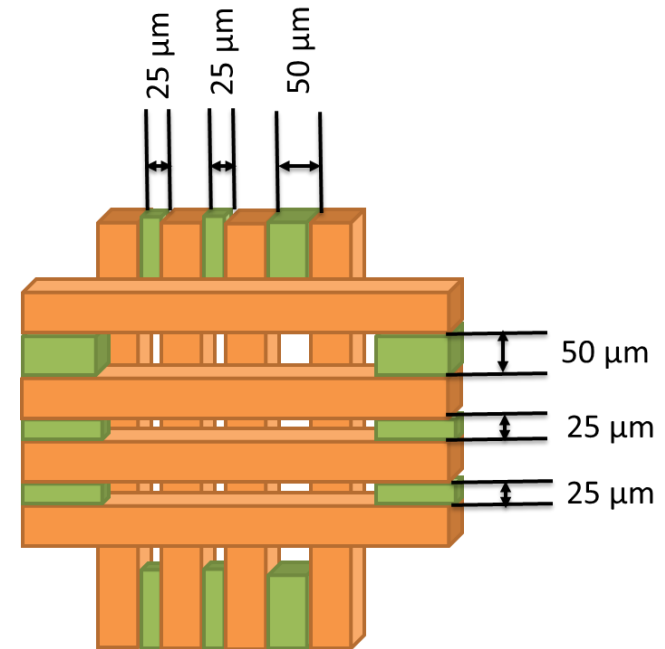
- Diffraction contribution to PSF from pinhole **worsens with distance** given a fixed aperture size  $A$ :

$$\sigma_{\text{Diffraction}} = \frac{\sqrt{12}}{4\pi} \frac{\lambda d_i}{A} \quad \text{for wavelength } \lambda \text{ [5].}$$



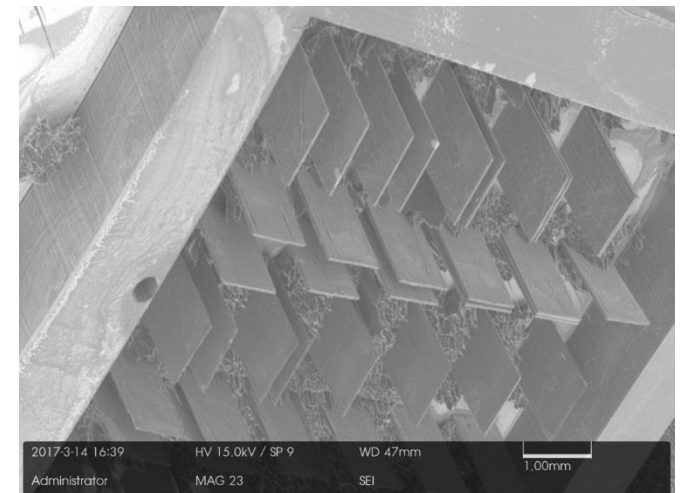
- Pinhole fabrication

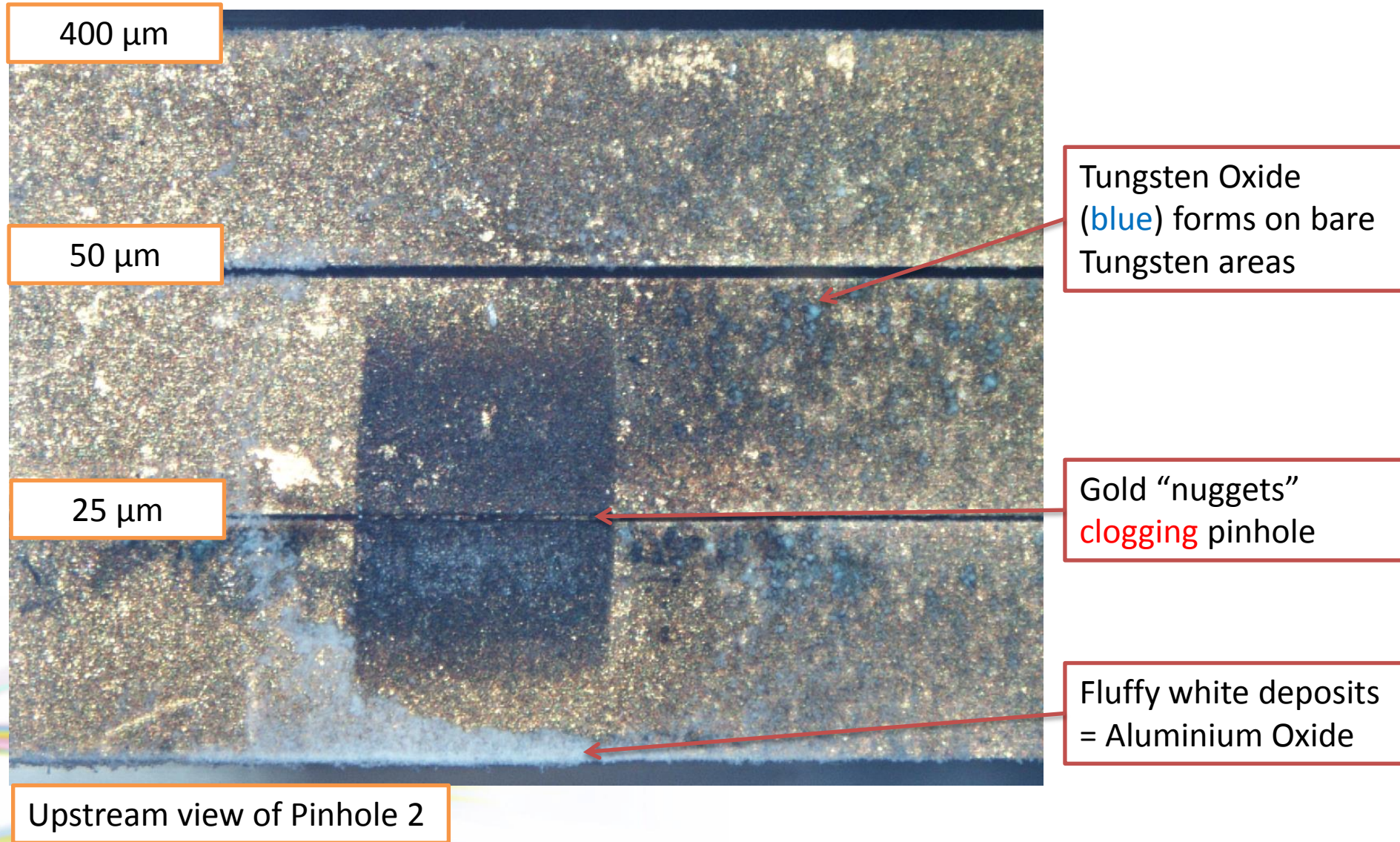
- For the pinhole to be opaque to keV X-rays a **high Z material** is required e.g. 1mm thick Tungsten.
- Often these materials are **difficult to machine**.
- Especially given the **high aspect ratio** 10  $\mu\text{m}$  (aperture): 1mm (thickness)  
 → **1:100**



- Environment and oxidation

- Air, nitrogen or vacuum?
- Lifetime and **maintenance considerations**





- **Simple** design. **Simple** alignment. **Simple** maintenance. **Simple** analysis. **Simple...**
  - Quick to commission e.g. < 1 week at Diamond (2006)
  - So simple, a human can learn a lot just by looking...!
- Provides **2D transverse profile**.
- **Non-invasive**.
- **Cheap** options are available.
- Possible to **custom build** the imager to optimise for spatial resolution, turn-by-turn acquisition, dynamic range etc.
- Fast image processing, thus **suitable for feedback systems**.

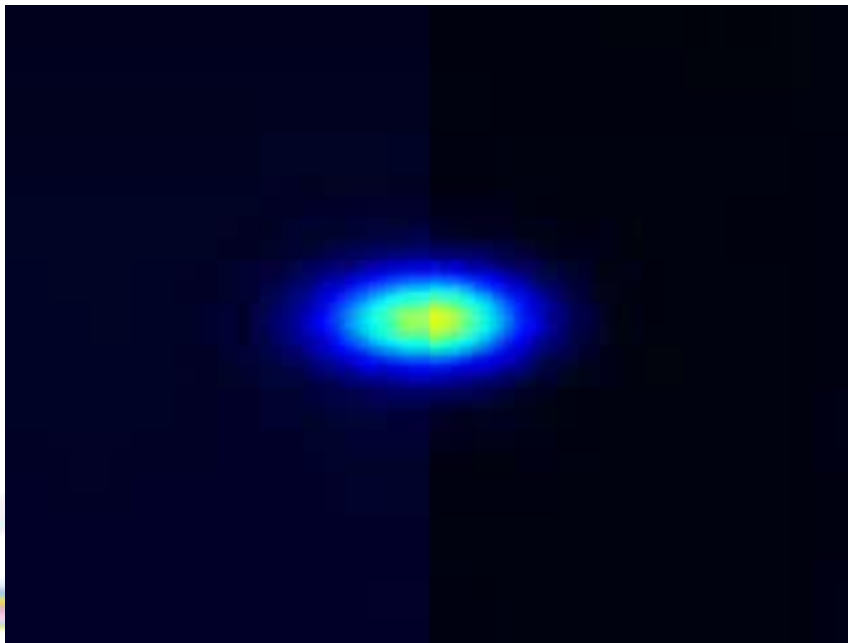
Emittance Monitoring

+

CCTV



*While we have human operators, the importance of easy human interpretation shouldn't be overlooked.*



Injection at Diamond 2015



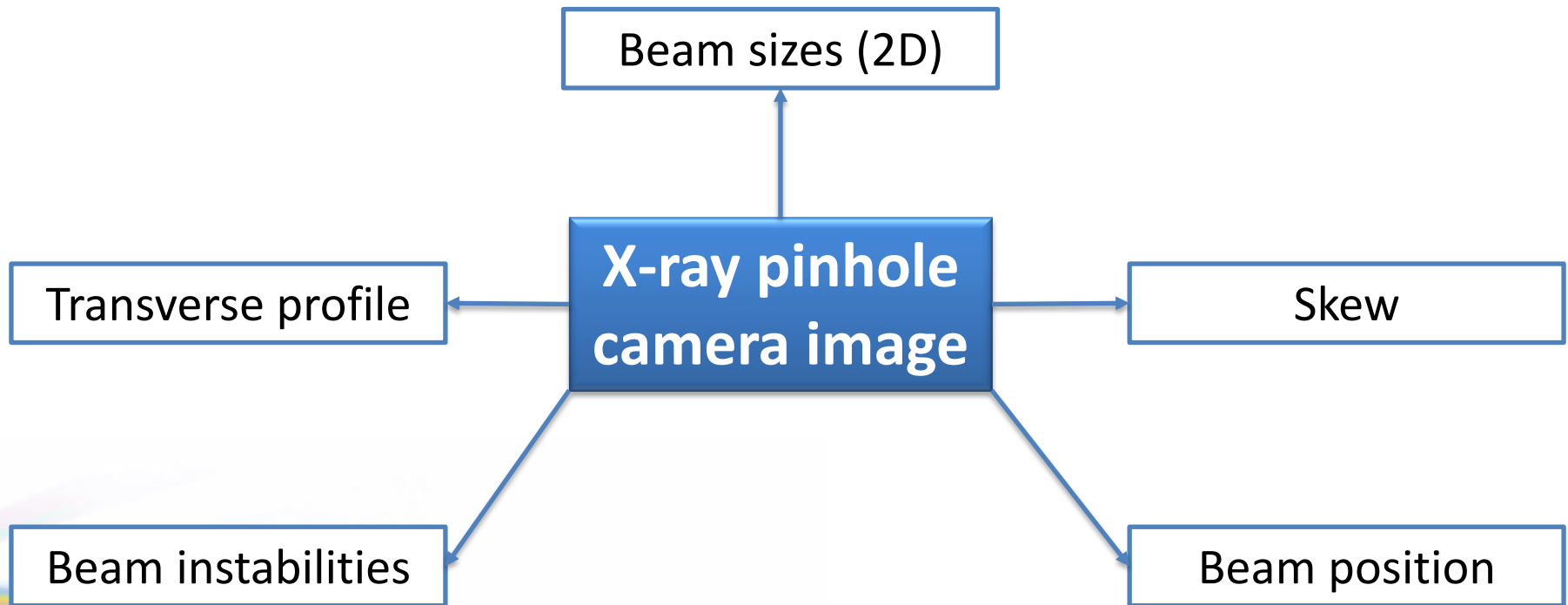
TMBF at Diamond 2015

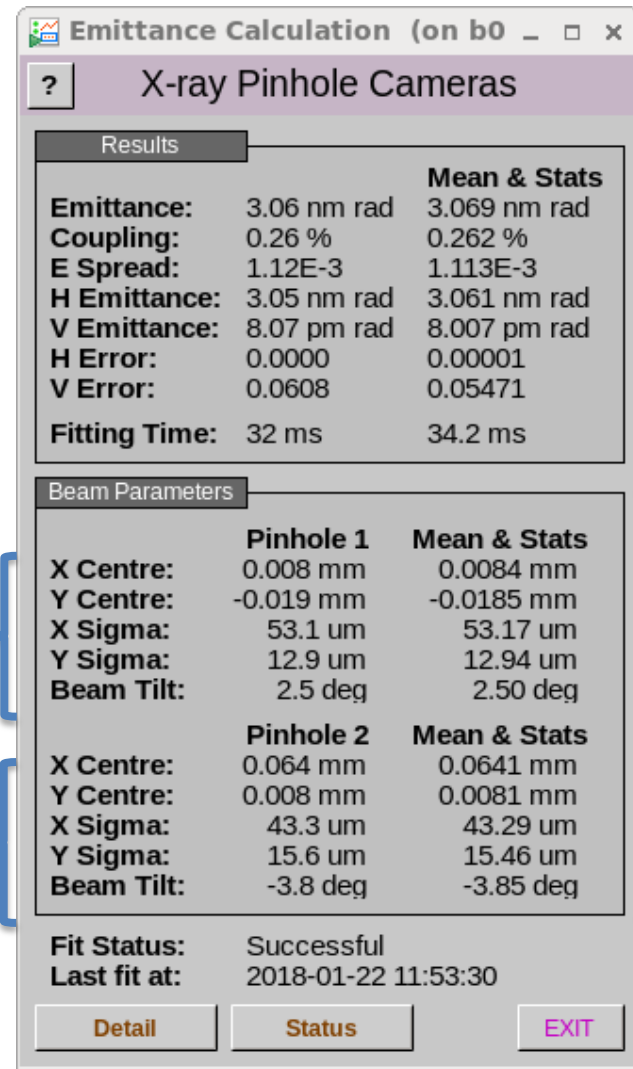
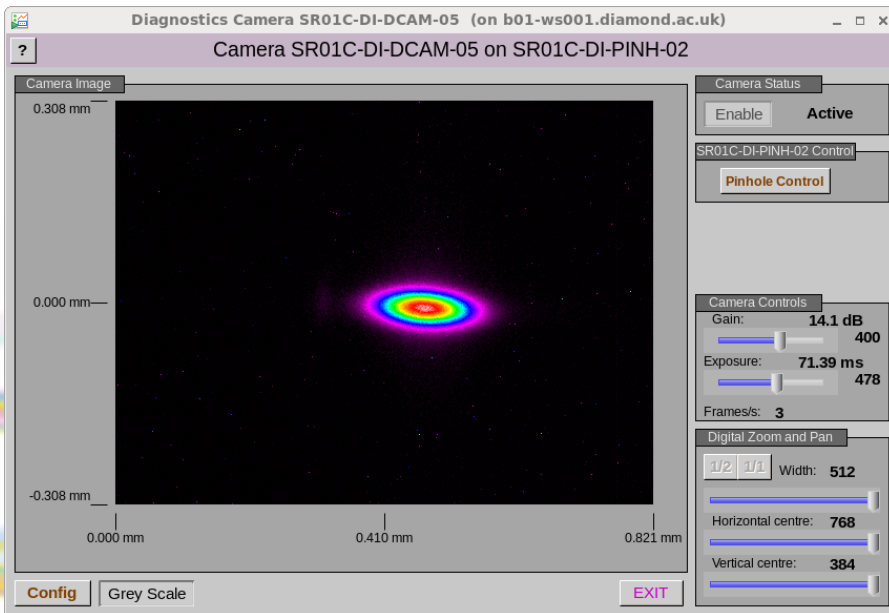
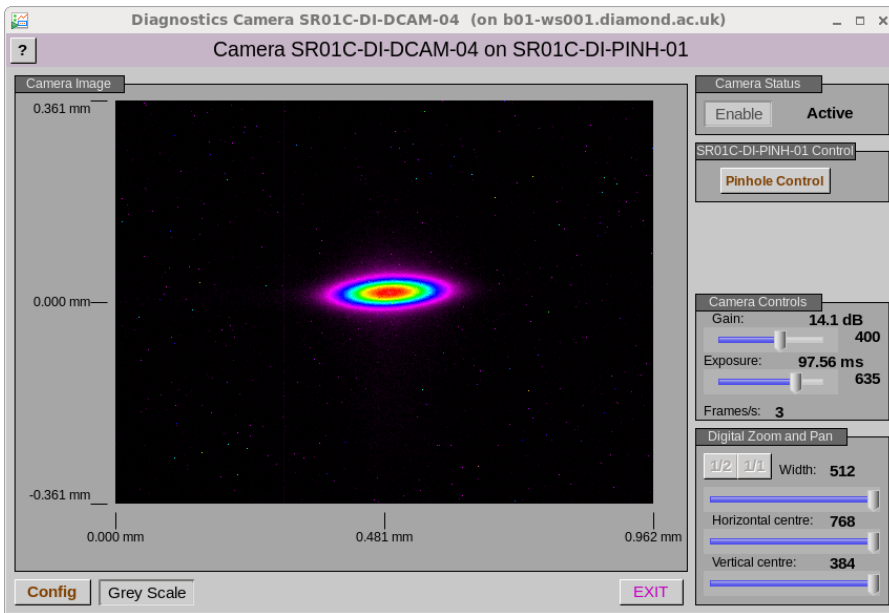


**Emittance Monitoring**

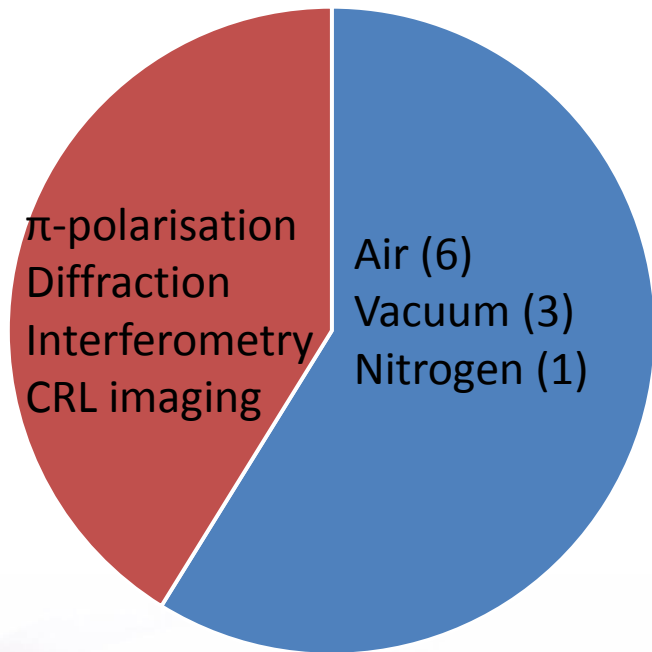
+

**CCTV**



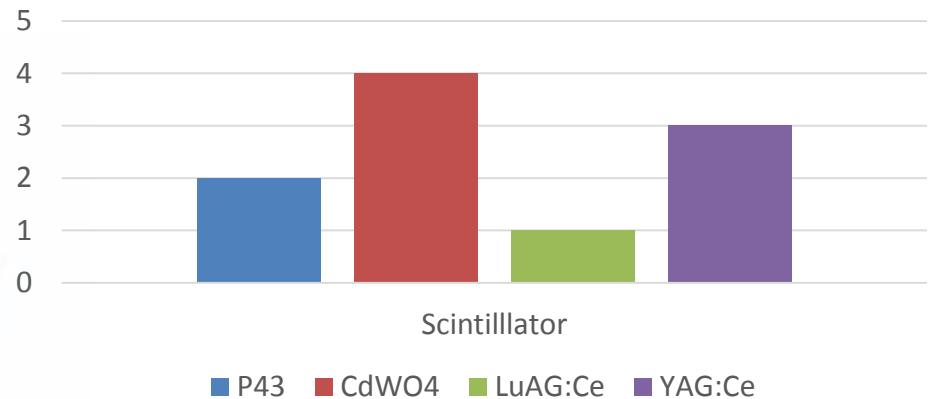


Do you use X-ray pinhole cameras for emittance measurement?



■ Yes (10) ■ No (7)

Parameter	Average
Aperture	23 μm
X-ray energy	29 keV
$\left(\frac{\sigma_{PSF}}{\sigma_y}\right) \times 100$	32 %
Source-to-screen magnification	1.6
Screen-to-camera magnification	1.8



■ P43 ■ CdWO4 ■ LuAG:Ce ■ YAG:Ce

- Simple! → Easy to commission → Easy maintenance
- Survey shows primary instrument for emittance monitoring
- Fundamental limitations, given space and 30 keV X-rays etc., mean sub-micron beam size measurements are not possible.
- Many practical challenges are being improved with technological advances.
- Complementary general diagnostic → CCTV
- Suitable for emittance feedback
- Easy human interpretation

- [1] V. Popovic *et al.*, Design and Implementation of Real-Time Multi-Sensor Vision Systems, Springer, 2017.
- [2] E. S. Forster, Problemata by Aristotle, translated to English, Vol VII, 912b, 1927.
- [3] E. Renner, Pinhole Photography from Historic Technique to Digital Application, Fourth Ed., Focal Press, 2009.
- [4] C. Thomas *et al.*, *X-ray pinhole camera resolution and emittance measurement*, Phys. Rev. ST Accel. Beams **13**, 022805 (2010).
- [5] P. Elleaume *et al.*, J. Synchrotron Radiat. 2, 209 (1995).
- [6] M. Madou, ``Chapter 10: Micromolding Techniques - LIGA'', Fundamentals of Microfabrication and Nanotechnology, Vol. 2, Third Ed., CRC Press, 2012, p.591-642.
- [7] L.M. Bobb *et al.*, ``Performance Evaluation of Molybdenum Blades in an X-ray Pinhole Camera'', Proc. IBIC2016, p. 796-799.

**Thank you for your attention.**

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